

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Trung T. Doan

Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

Docket No.: 303.928US5

Serial No.: 09/652,713

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Examiner: Sylvia MacArthur

Group Art Unit: 1763

**MS AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ Notice Of Appeal From The Decision Of The Examiner To The Board Of Patent Appeals And Interferences (1 pg.) including authorization to charge Deposit Account 19-0743 in the amount of \$500.00 for Notice of Appeal Fee.

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

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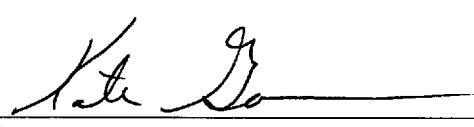
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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 19 day of April, 2007.

  
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(GENERAL)